



#6/A
11-5-02
AJONES

00862.022398.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Toru SUZUKI) Examiner: D. Esplin
Application No.: 09/965,801 ✓) Group Art Unit: 2851
Filed: October 1, 2001)
For: SCANNING EXPOSURE APPARATUS ✓) October 31, 2002
AND METHOD)

The Commissioner for Patents
Washington, D.C. 20231

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TECHNOLOGY CENTER, 2000

AMENDMENT

Sir:

In response to the Official Action dated July 31, 2002, please amend the above-identified application as follows:

IN THE ABSTRACT: ✓

Please cancel the current abstract and insert the following. A marked-up copy showing the changes made to the abstract is attached hereto in Appendix A.

A -- A scanning exposure apparatus for transferring a pattern of a master onto each of a plurality of shot regions defined on a substrate, while synchronously scanning the master and the substrate. The apparatus includes a master stage for moving the master, a substrate stage for moving the substrate, and a controller for controlling movement of the substrate stage during scanning exposure of the plurality of shot regions so as to assure that a setting distance in which